| | Application Number | 10/589,741 |
|------------------------|------------------------|-------------------|
| SUPPLEMENTAL | Filing Date | August 16, 2006 |
| INFORMATION DISCLOSURE | First Named Inventor | Michael J. Sailor |
| STATEMENT BY APPLICANT | Art Unit | 2876 |
| | Examiner Name | Michael S. Andler |
| Sheet 1 of 2 | Attorney Docket Number | 0321.68812 |

| UNITED STATES PATENTS | | | | |
|---|--------------|------------|------------------|---|
| Examiner Initials* | Document No. | Dated | inventor | |
| | 4,390,452 | 06-28-1983 | Stevens | |
| | 5,301,204 | 04-05-1994 | Cho et. al. | |
| | 6,096,496 | 08-01-2000 | Frankel | |
| | 6,130,748 | 10-10-2000 | Kruger et. al. | |
| | 6,206,065 | 03-27-2001 | Robbie et. al. | |
| | 6,255,709 | 07-03-2001 | Marso et. al. | |
| | 6,690,027 | 02-10-2004 | Bensahel et. al. | |
| *************************************** | 6,919,009 | 07-19-2005 | Stonas et. al. | |
| *************************************** | 7,225,082 | 05-29-2007 | Natan et. al. | *************************************** |
| | 7,241.629 | 07-10-2007 | Deineka et. al. | ~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~ |

| | | NON PATENT LITERATURE DOCUMENTS | |
|-----------------------|-------------|--|---|
| Examiner Initials* | Cite No. | include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), city and/or country where published. | T |
| | 1. | FAUCHET, Philippe M., "The integration of nanoscale porus silicon light emitters: materials, science, properties, and integration with electronic circuitry" Journal of Luminescence, 80, 1990, pp.53-64 | |
| | 2. | JANSHOFF, Andreas et. al., "Macroporous p-Type Fabry-Perot Layers, Fabrication, Characterization and Applications in Biosensing", Journal of American Chemical Society, 1998, 120, pp. 12108-12116 | |
| | 3. | LAMMEL, G. et al., "Microspectrometer based on a tunable optical filter of porous silicon", Sensors and Actuators, A 92, 2001, pp.52-59 | |
| | 4, | LETANT, Sonia E. et. al., "Molecular Identification by Time-Resolved Interfermetry in a Porous Silicon Film", Advanced Materials, 2001, 13, pp.335-338 | |
| | 5. | MATTEI, G., et. al., "Enhancement of adsorbate vibrations due to interaction with microcavity mode in porous silicon superlattice", Surface Science, 427-428 (1999) 235-238 | |
| | 6. | SETZU, S. et. al, "Optical properties of multilayered porous silicon", Materials Science and Engineering, B69-70, 2000, pp. 34-42 | |
| | 7. | SQUIRE, E.K. et. al., "Light emission from porous silicon single and multiple cavities", <i>Journal of Luminescence</i> , 80, 1999, pp. 125-128 | |
| | 8. | ZHOU, Y. et. al., "The Effect of Thermal Processing on Mulitlayer Porous Silicon Microcavity", <i>Phsy. Stat. Sol.</i> , 182, 2000, pp. 319-324 | |

| | Application Number | 10/589,741 |
|------------------------|------------------------|-------------------|
| SUPPLEMENTAL | Filing Date | August 16, 2006 |
| INFORMATION DISCLOSURE | First Named Inventor | Michael J. Sailor |
| STATEMENT BY APPLICANT | Art Unit | 2876 |
| | Examiner Name | Michael S. Andler |
| Sheet 2 of 2 | Attorney Docket Number | 0321.68812 |

| OTHER DOCUMENTS | | | | |
|--------------------|-----------------------|----------|----------------|-------------|
| Examiner Initials* | Document No. | Dated | Inventor | Translation |
| | Office Action from | | | |
| | Serial No. 10/503,217 | 02/05/10 | Sailor et. al. | |